



**ELECTRONIC COPY**

LG786679700  
Report verification at igi.org



March 30, 2026

IGI Report Number **LG786679700**

Description **LABORATORY GROWN DIAMOND**

Shape and Cutting Style **EMERALD CUT**

Measurements **8.44 X 6.00 X 4.16 MM**

**GRADING RESULTS**

Carat Weight **2.06 CARATS**

Color Grade **F**

Clarity Grade **VS 1**

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**ADDITIONAL GRADING INFORMATION**

Polish **EXCELLENT**

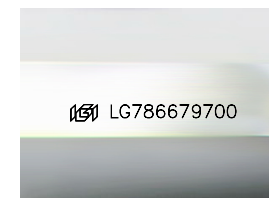
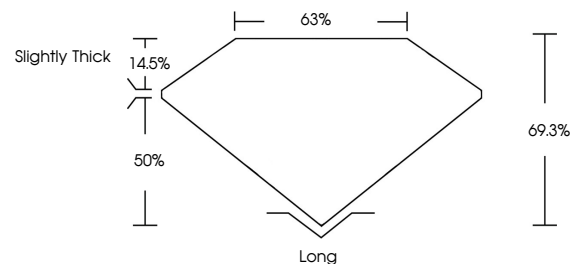
Symmetry **EXCELLENT**

Fluorescence **NONE**

Inscription(s) **IGI LG786679700**

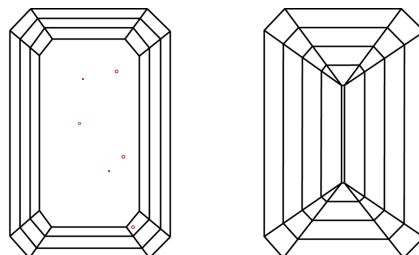
Comments: This Laboratory Grown Diamond was created by Chemical Vapor Deposition (CVD) growth process. Type IIa

**PROPORTIONS**



Sample Image Used

**CLARITY CHARACTERISTICS**



**KEY TO SYMBOLS**

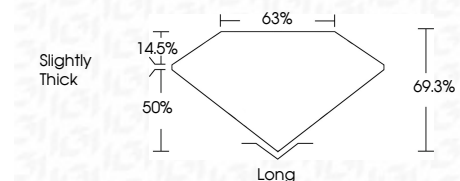
Red symbols indicate internal characteristics.  
Green symbols indicate external characteristics.

**COLOR**

D E F G H I J Faint Very Light Light

**CLARITY**

FL	IF	VS <sup>1-2</sup>	VS <sup>1-2</sup>	SI <sup>1-2</sup>	I <sup>1-3</sup>
Flawless	Internally Flawless	Very Very Slightly Included	Very Slightly Included	Slightly Included	Included



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Symmetry **EXCELLENT**

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**IGI**



March 30, 2026  
IGI Report No LG786679700  
**EMERALD CUT**

**2.06 CARATS**  
F

8.44 X 6.00 X 4.16 MM  
Color Grade  
Clarity Grade  
Table  
Depth  
Girdle

VS 1  
69.3%  
63%  
Slightly Thick

Long  
Culet  
Polish  
Symmetry  
Fluorescence  
Inscription(s)

EXCELLENT  
EXCELLENT  
NONE  
IGI LG786679700

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